

Applicant: Johnny Zhong et al.
Serial No.: 10/698,581
Filing Date: October 31, 2003
For: THIN FILM INTERLEAVER

Confirmation No.: 1109
Att'y Docket No.: 15436.132.1
Group: 2874

References Cited by Applicants

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The reference designations "A1," "A2," etc. (referring to Applicant's reference 1, Applicant's reference 2, etc.) will be used by the Examiner in the same manner as Examiner's reference designations "A," "B," "C," etc. on Office Action Form PTO-1142.

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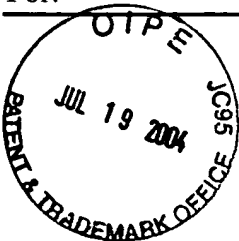
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INFORMATION DISCLOSURE CITATIONS MADE BY APPLICANT

U.S. Patent Documents

<u>Examiner Initial*</u>	<u>Document Number</u>	<u>Issue Date</u>	<u>Name</u>
____ 1	6,421,177	07/16/2002	Leyva et al.
____ 2	6,256,433	07/03/2001	Luo et al.

Foreign Patent Documents

<u>Examiner Initial*</u>	<u>Document Number</u>	<u>Publication Date</u>	<u>Country or Patent Office</u>	<u>Translation</u>
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Other Documents

(including author, title, pertinent pages, etc.)

<u>Examiner Initial*</u>	
____ 3	Nick Herring, <i>The E-Tek Interleaver with Lowest Dispersion</i> , BFi OPTiLAS, June 20, 2000.
____ 4	Stephane Bourgeois, <i>Fused-Fiber Developments: Offer Passive Foundation for Optical Slicing</i> , Lightwave Special Report, March 4, 2000.
____ 5	Joseph C. Chon et al., <i>Ultra-high Capacity and High Speed DWDM Optical Devices for Telecom and Datacom Application</i> , Proceedings of SPIE, Vol. 4581, 2001, pp. 13-20.
____ 6	Wavesplitter Lighting the Internet on Fiber Catalog, <i>Creating Unique Advantages Together</i> , WaveProcessor F ³ T Interleaver, February 2002.

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